

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:	)	
	)	
Fei-Gwo Tsai	)	Group Art Unit: 1756
	)	
Serial No.: 10/725,810	)	Examiner: Young, Christopher G.
	)	
Filed: December 2, 2003	)	Confirmation No.: 3323
	)	
For: <b>Method of Adjustable Matching Map</b>	)	TKHR Docket: 252016-2480
<b>System in Lithography</b>	)	Top-Team: 0503-7672US
	)	

**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed August 8, 2006 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.